Kim et al. *Light: Science & Applications* (2023)12:68
https://doi.org/10.1038/s41377-023-01086-6

Official journal of the CIOMP 2047-7538
www.nature.com/lsa

ARTICLE Open Access

One-step printable platform for high-efficiency metasurfaces down to the deep-ultraviolet region

Joohoon Kim[1], Wonjoong Kim[2], Dong Kyo Oh[1], Hyunjung Kang[1], Hongyoon Kim[1], Trevon Badloe[1], Seokwoo Kim[1], Chanwoong Park[2], Hojung Choi[2], Heon Lee[2]✉ and Junsuk Rho[1,3,4,5]✉

Abstract

A single-step printable platform for ultraviolet (UV) metasurfaces is introduced to overcome both the scarcity of low-loss UV materials and manufacturing limitations of high cost and low throughput. By dispersing zirconium dioxide (ZrO_2) nanoparticles in a UV-curable resin, ZrO_2 nanoparticle-embedded-resin (nano-PER) is developed as a printable material which has a high refractive index and low extinction coefficient from near-UV to deep-UV. In ZrO_2 nano-PER, the UV-curable resin enables direct pattern transfer and ZrO_2 nanoparticles increase the refractive index of the composite while maintaining a large bandgap. With this concept, UV metasurfaces can be fabricated in a single step by nanoimprint lithography. As a proof of concept, UV metaholograms operating in near-UV and deep-UV are experimentally demonstrated with vivid and clear holographic images. The proposed method enables repeat and rapid manufacturing of UV metasurfaces, and thus will bring UV metasurfaces more close to real life.

Introduction

Ultraviolet (UV) optics play a critical role in numerous applications such as high-resolution imaging[1,2], spectroscopy[3], quantum optics[4,5], photolithography[6], and biosensing[7,8]. So far, UV light is mostly modulated using conventional bulky optical components which hinder the integration of compact systems. Moreover, conventional UV optics are limited in functionality, diversity, and manufacturability.

Metasurfaces composed of subwavelength structure arrays have been actively studied to replace conventional bulky optics, and with the exceptional ability to modulate light at the nanoscale have been applied to numerous applications such as metalenses[9,10], biosensors[11,12], metaholograms[13–21], and color printing[22–26]. However, UV metasurfaces have long faced challenges such as a lack of UV transparent materials and high-resolution patterning techniques with low cost and high throughput. Conventional high-refractive-index materials used for metasurfaces usually have a narrow bandgap, resulting in high absorption of UV light[27]. So far, very few materials such as silicon nitride (SiN_x)[28], hafnium oxide (HfO_2)[29], zinc oxide (ZnO)[30], and niobium pentoxide (Nb_2O_5)[31] have been used for UV metasurfaces; however, the fabrication of those UV metasurfaces involves atomic layer deposition of thick layers or high-aspect-ratio etching, resulting in complicated fabrication process with the high cost and low throughput. Moreover, in all of the aforementioned UV metasurfaces, electron beam lithography (EBL) has been used for high-resolution patterning of subwavelength structures. These fabrication processes cause manufacturing limitations, such as high cost and low throughput, resulting in challenges in the commercialization of UV metasurfaces.

Here, we introduce a one-step printable platform for high-efficiency metasurface operating over a broad UV range from near-UV to deep-UV region (Fig. 1a). Zirconium dioxide (ZrO_2) nanoparticle embedded resin (nano-PER), a printable material with a large bandgap and high

Correspondence: Heon Lee (heonlee@korea.ac.kr) or
Junsuk Rho (jsrho@postech.ac.kr)
[1]Department of Mechanical Engineering, Pohang University of Science and Technology (POSTECH), Pohang 37673, Republic of Korea
[2]Department of Materials Science and Engineering, Korea University, Seoul 02841, Republic of Korea
Full list of author information is available at the end of the article
These authors contributed equally: Joohoon Kim, Wonjoong Kim, Dong Kyo Oh

© The Author(s) 2023
Open Access This article is licensed under a Creative Commons Attribution 4.0 International License, which permits use, sharing, adaptation, distribution and reproduction in any medium or format, as long as you give appropriate credit to the original author(s) and the source, provide a link to the Creative Commons license, and indicate if changes were made. The images or other third party material in this article are included in the article's Creative Commons license, unless indicated otherwise in a credit line to the material. If material is not included in the article's Creative Commons license and your intended use is not permitted by statutory regulation or exceeds the permitted use, you will need to obtain permission directly from the copyright holder. To view a copy of this license, visit http://creativecommons.org/licenses/by/4.0/.

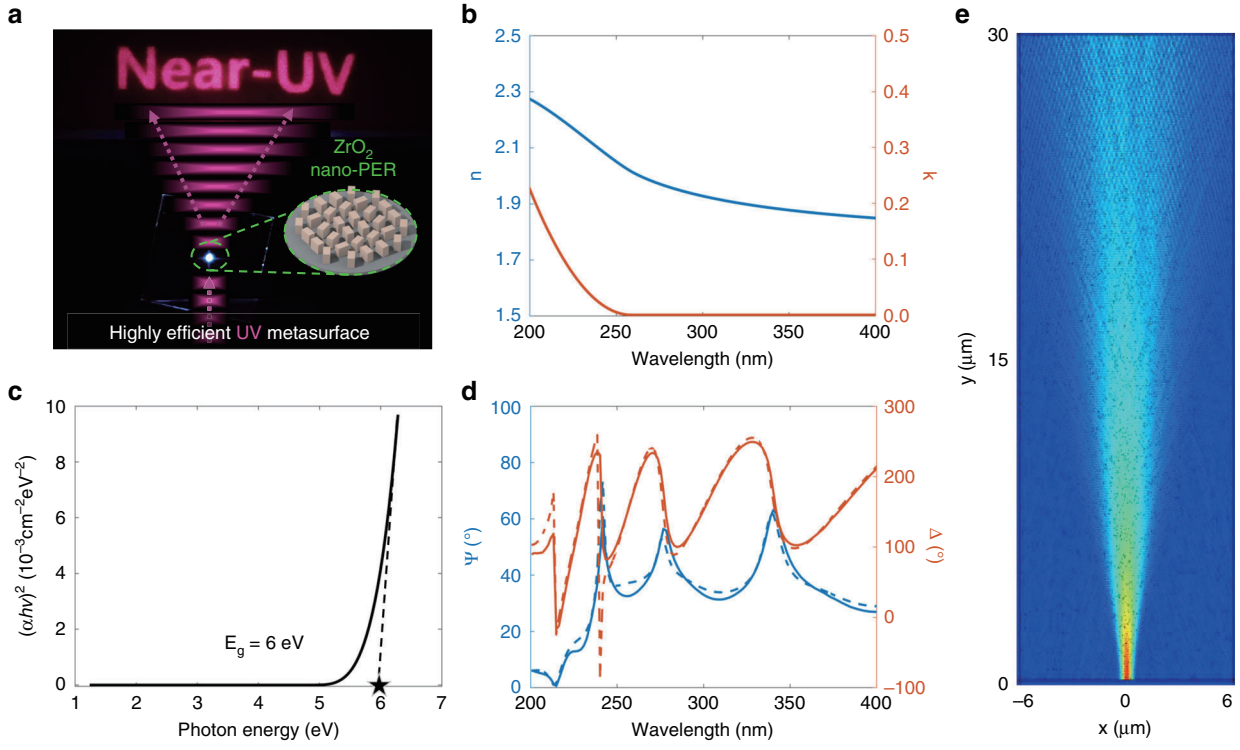

Fig. 1 Optical characterization of ZrO_2 nano-PER. a Schematic of the UV metasurface made up of ZrO_2 nano-PER. **b** Measured complex refractive index of ZrO_2 nano-PER film. Blue line represents the refractive index (n) and the orange line represents the extinction coefficient (k). **c** Calculated optical band gap of ZrO_2 nano-PER film. **d** Measured amplitude ratio and phase difference of ZrO_2 nano-PER film using ellipsometry. (Solid line: measured data; dashed line: model data) **e** Simulated scattering effect of a Gaussian beam propagating in the nano-PER film

refractive index over a wide UV range, is newly proposed. ZrO_2 nano-PER is synthesized by dispersing ZrO_2 nanoparticles in a UV-curable resin. The proposed one-step printable platform enables direct replication of UV metasurfaces without the need for any secondary operations, resulting in extremely high throughput and low cost. The metasurface can achieve a high conversion efficiency owing to the high refractive index and low extinction coefficient of ZrO_2 nano-PER. As a proof of concept, we experimentally demonstrate a metahologram operating in near-UV (325 nm) and deep-UV (248 nm).

Results

Characteristics of ZrO_2 nano-PER

The key to a one-step printable UV metasurfaces is to produce a printable material that has a high refractive index (n) and low extinction coefficient (k) in the UV region. However, conventional printable materials such as imprint resin have a low refractive index of approximately 1.5. Recently, we developed a titanium dioxide (TiO_2) nano-PER with $n \approx 1.95$ in the visible region and silicon (Si) nano-PER with $n \approx 2.2$ in the near-infrared region; however, both materials have severe absorption in the UV region owing to their small optical band gap[32–36]. Therefore, a high-n printable material with a large optical bandgap is required for high-efficiency UV metasurfaces.

The ZrO_2 nano-PER developed here can be used as a UV transparent printable material with a high refractive index (Fig. 1b). The ZrO_2 nano-PER has a large bandgap of 6 eV which leads to low absorption in the UV region (Fig. 1c, Fig. S1). The ZrO_2 nano-PER is synthesized by dispersing 19 nm diameter ZrO_2 nanoparticles with an 80% weight ratio into a UV-curable resin which makes the nano-PER printable (Fig. S2). As the weight ratio increases, the refractive index also increases (Fig. S3). However, the highest weight ratio is 80% because imprinting becomes difficult as the ratio increases over 80%. The complex refractive index of the ZrO_2 nano-PER film is calculated by measuring the amplitude ratio (Ψ) and phase difference (Δ) between the s and p components of three different angles (65°, 70°, 75°) using ellipsometry (Fig. S4). In order for the nano-PER to operate as a meta-atom, the nano-PER should act as a homogeneous effective medium. The measured Ψ and Δ fit well with the Tauc-Lorentz model[37], which provides the validity of the ZrO_2 nano-PER as the homogeneous effective medium (Fig. 1d). Moreover, the scattering effect of a Gaussian beam in the ZrO_2 nano-PER is simulated to confirm that

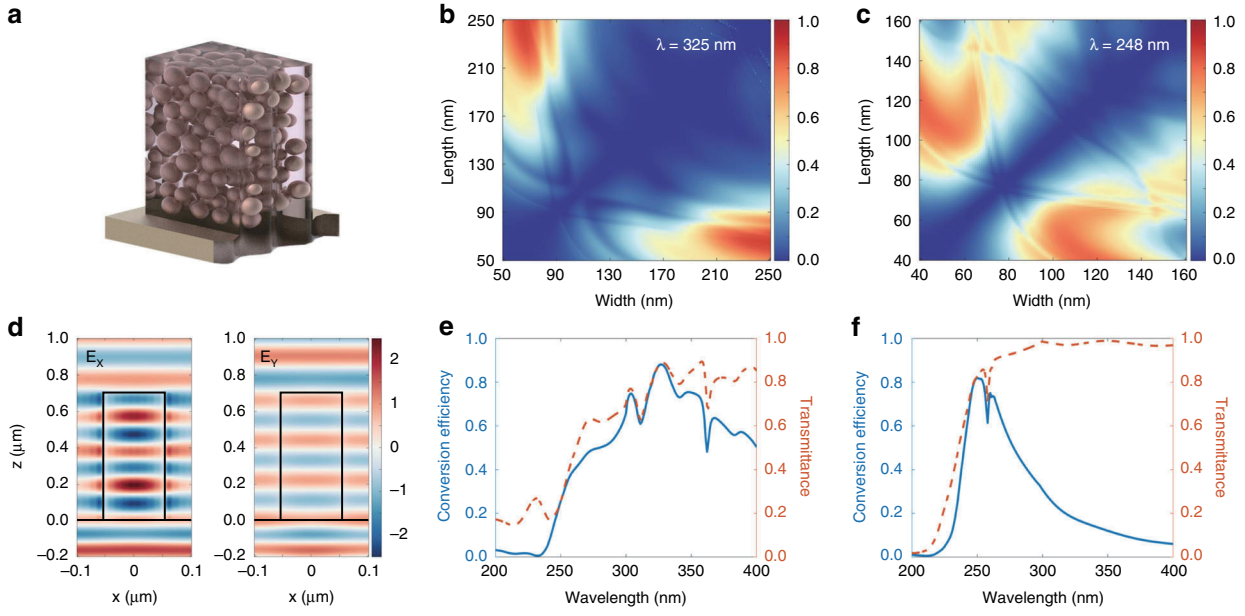

Fig. 2 Design and simulation of the high-efficiency meta-atom operating in near-UV and deep-UV. a Schematic illustration of the printable meta-atom consisting of ZrO_2 nano-PER. **b** Simulated conversion efficiencies for meta-atoms at λ = 325 nm. Width and length parameters are varied from 50 nm to 250 nm with fixed height (700 nm) and period (300 nm). **c** Simulated conversion efficiencies for meta-atoms at λ = 248 nm. Width and length parameters are varied from 40 nm to 160 nm with fixed height (700 nm) and period (200 nm). **d** Simulated electric field profiles at λ = 248 nm. Real part of the *x* component (left) and *y* component (right) of the electric field. Simulated conversion efficiency and transmittance of designed meta-atom operating in **e** λ = 325 nm and **f** λ = 248 nm

the nano-PER acts as an effective medium (Fig. 1e). The diameter of the ZrO_2 nanoparticles follows a Gaussian distribution of 19 nm on average. Owing to small particle size, the scattering effect is negligible, and the Gaussian beam maintains its shape as it propagates. These results prove that the ZrO_2 nano-PER can act as an effective medium and can be applied for use in a metasurface.

Design of high-efficiency UV meta-atoms

Rigorous coupled-wave analysis (RCWA)[38] was used to simulate the transmission properties of meta-atoms consisting of ZrO_2 nano-PER. To achieve full phase modulation with broadband property, the concept of the Pancharatnam-Berry phase (PB phase)[16], also known as geometric phase[39,40], is used to physically realize the required phase profile (Supplementary Note 1). PB phase uses an anisotropic meta-atom which is a birefringence (Fig. 2a). Transmitted light with a converted handedness of polarization (cross-polarization) has a phase delay of 2θ. The amplitude of the cross-polarized component is defined as a conversion efficiency that is directly related to the efficiency of the meta-atom.

The final goal of this work is to design high-efficiency meta-atoms operating from near-UV (325 nm) down to deep-UV (248 nm). For the near-UV meta-atom, we calculate the conversion efficiencies of meta-atoms with varying lengths and widths from 50 nm to 250 nm with a fixed height of 700 nm and periodicity of 300 nm (Fig. 2b). The meta-atom with a length of 250 nm and a width of 65 nm has a conversion efficiency of 88% at a wavelength of 325 nm. For deep-UV meta-atom, we calculate conversion efficiencies of meta-atom varying lengths and widths from 40 nm to 160 nm with a fixed height of 700 nm and periodicity of 200 nm (Fig. 2c). The meta-atom with a length of 110 nm and a width of 45 nm has a conversion efficiency of 81% at a wavelength of 248 nm. The height is optimized for maximum conversion efficiency (Fig. S5), and periodicity is determined to be smaller than the operating wavelength to suppress the diffraction of transmitted light. Notably, candidate meta-atoms near the target geometry still have high efficiency, therefore some fabrication errors are acceptable. The ideal PB phase meta-atom should provide a π–phase difference between the *x* and *y* components of the electric field ($\mathbf{E_x}$ and $\mathbf{E_y}$), and act as a half-wave plate. We plot real values of the propagating electric field profiles of *x*- and *y*-polarized light in designed meta-atoms at the designed wavelength of 325 nm and 248 nm (Fig. 2d, Fig. S6). We confirm that designed meta-atoms provide a π–phase difference between the *x* and *y* components of the electric field and act as a half-wave plate, therefore operating as an ideal PB phase meta-atom. Owing to the broadband property of the PB phase, the meta-atom designed for 325 and 248 nm has high efficiency and low zero-order efficiency near the target wavelength, respectively (Fig. 2e, f, Fig. S7). Owing to

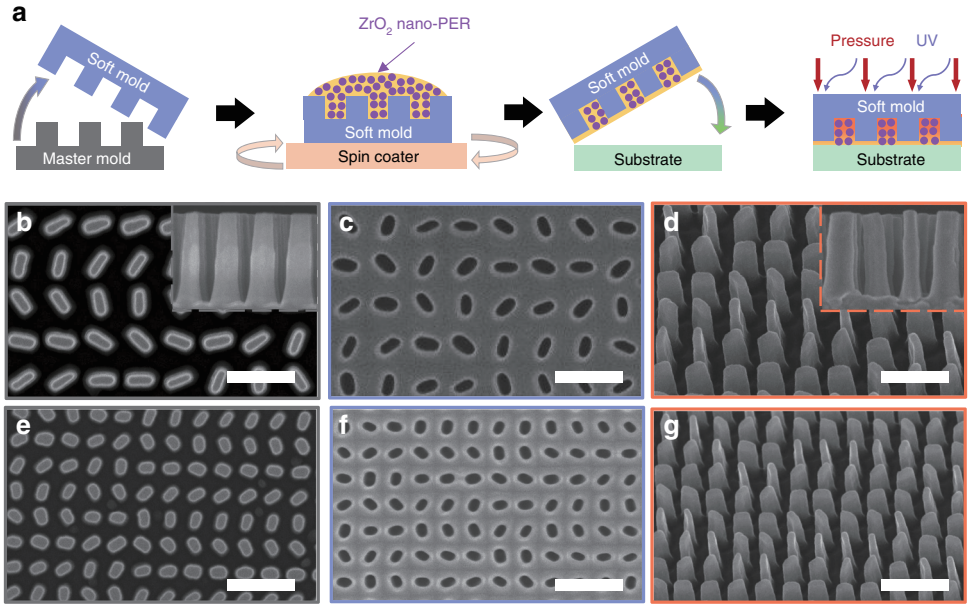

Fig. 3 Fabrication of UV metaholographic device using the one-step printable process of ZrO2 nano-PER. a Schematic of the one-step printable platform for fabrication of the UV metaholographic device. SEM images of **b** the master mold, **c** the soft mold, and **d** the one-step printed UV metasurface of the target hologram designed for λ = 325 nm. (Inset) cross-section view. SEM images of **e** the master mold, **f** the soft mold, and **g** the one-step printed UV metasurface of the target hologram designed for λ = 248 nm. All scale bars: 500 nm

the low extinction coefficient of ZrO_2 nano-PER, the designed meta-atom has high transmittance and low absorption in the UV region (Fig. S8).

One-step printable platform for ZrO_2 nano-PER based UV metasurface

A schematic for the one-step printable platform for ZrO_2 nano-PER-based UV metasurface is described in Fig. 3a. First, master molds with different scales for metasurfaces operating at λ = 325 nm and 248 nm are fabricated by conventional EBL, mask deposition, and lift-off process, respectively (details in the *Methods*, Fig. 3b, e). Then, the fabricated master molds are covered with a hard-polydimethylsiloxane (h-PDMS)/PDMS bilayer and cured by heat for the successful transfer of extremely small meta-atoms with 50-nm resolution (Fig. 3c, f)[41]. The 80 wt % ZrO_2 nano-PER in the MIBK solvent is spin-coated on soft molds to achieve the uniform ZrO_2 nano-PER thin film with an optimal residual layer thickness which affects the final conversion efficiency and reflectivity of UV metasurfaces(Fig. 3d, g)[32]. It is beyond any doubt that the conformally coated ZrO_2 nano-PER layer fits perfectly with the flat target substrate. Plus, an additional PMMA layer between the ZrO_2 nano-PER and substrates can underpin non-trivial enhancement of work of adhesion, which is suitable for the facile transfer on any arbitrary substrate[32]. To finish, the adequate pressurization and UV illumination achieve UV metasurfaces operating at λ = 325 nm and 248 nm, respectively.

Design and demonstration of a UV metahologram

We design a simple Fraunhofer hologram as a representative wavefront shaping function of the designed UV metasurface. The Gerchberg-Saxton (GS) algorithm is used to retrieve the phase map for high-quality phase-only holograms[42]. Since Fraunhofer approximation results in a pincushion-like distortion in the recovered hologram, barrel distortion is used to compensate for the distortion by trial and error. By modulating the phase profile with the designed meta-atoms, we design and demonstrate high-quality UV metaholograms operating in the near-UV and deep-UV. The optical setup for UV metaholograms is prepared as shown in Fig. 4a. A helium cadmium (HeCd) laser is used for λ = 325 nm, and a krypton fluoride (KrF) laser is used for λ = 248 nm. Two UV wave plates, a linear polarizer, and a quarter-wave plate are used to create the circularly polarized input beam. A UV sensor card is used to visualize the UV hologram. As we expected, demonstrated holographic images match well with simulated images and show a vivid and clear image in the near-UV (Fig. 4b, c) and deep-UV (Fig. 4d, e). Moreover, we experimentally measure the conversion efficiency of both metaholograms. The metahologram designed for near-UV regime has a measured conversion efficiency of 72.3% at λ = 325 nm, and the metahologram designed for deep-UV regime has a measured conversion efficiency of 48.6% at λ = 248 nm (**Table Sl**). We also confirmed that this work has higher efficiency compared to previously reported UV metasurfaces (Table S2).

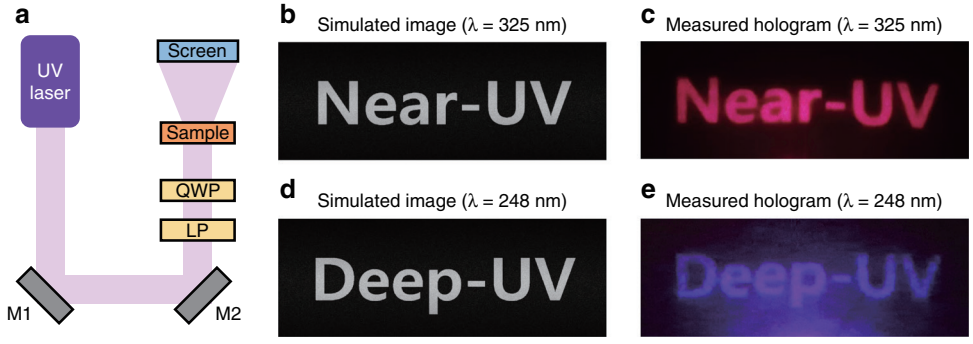

Fig. 4 Demonstration of the UV metahologram. a Optical setup for ZrO_2 nano-PER based UV metahologram (UV laser: HeCd laser for 325 nm, KrF laser for 248 nm; LP: linear polarizer; QWP: quarter-wave plate; Screen: UV sensor card). **b** Simulated and **c** measured image of the target hologram designed for λ = 325 nm. **d** Simulated and **e** measured image of the target hologram designed for λ = 248 nm

Discussions

In summary, we proposed and verified a one-step printable platform in which high-efficiency metasurfaces operating from near-UV to deep-UV can be replicated repeatably with low cost and high throughput. In detail, single ZrO_2 nano-PER metasurface can be fabricated in 15 minutes and costs around 1.39 USD (Table S3). The ZrO_2 nano-PER is synthesized as a printable material having high UV transparency and refractive index by dispersing ZrO_2 nanoparticles in a UV-curable resin. Owing to the UV-curable matrix, the UV metasurface consisting of the ZrO_2 nano-PER can be fabricated with one step of nanoimprint lithography without any secondary operations such as etching and deposition. The refractive index of the ZrO_2 nano-PER is high enough to confine the light well and the extinction coefficient is low enough to minimize the absorption, resulting in high conversion efficiency. The simulated conversion efficiency of the designed meta-atoms achieve 88% for λ = 325 nm and 81% for λ = 248 nm, respectively. As a proof of concept, we experimentally demonstrate a clear and vivid metahologram operating in near-UV and deep-UV. The demonstrated hologram has a conversion efficiency of 72.3% for λ = 325 nm and 48.6% for λ = 248 nm, respectively. We believe that this work will be a decisive improvement in the practicality of UV metasurfaces.

Methods

Synthesis of ZrO_2 nano-PER

The ZrO_2 nano-PER was prepared by mixing ZrO_2 NPs dispersed in MIBK (DT-ZROSOL-30MIBK (N10), Ditto technology), monomer (dipentaerythritol penta-/hexa-acrylate, Sigma-Aldrich), photo-initiator (1-Hydroxycyclohexyl phenyl ketone, Sigma-Aldrich), and MIBK solvent (MIBK, Duksan general science). The mixing ratio was controlled to achieve a weight ratio of 4 wt % for ZrO_2 NPs, 0.7 wt % for monomer, and 0.3 wt % for photo-initiator.

Fabrication of the master mold

A Si substrate was used for the master mold. The meta-atoms were transferred onto a bilayer of two positive tone photoresists (495 PMMA A6, MicroChem & 950 PMMA A2, MicroChem) using the standard EBL process (ELIONIX, ELS-7800; acceleration voltage: 80 kV, beam current: 100 pA). The exposed patterns were developed by MIBK/IPA 1:3 developer mixed solution. An 80 nm-thick chromium (Cr) layer was deposited using electron beam evaporation (KVT, KVE-ENS4004). The lifted-off Cr meta-atoms were used as an etching mask for the Si substrate. Cr patterns were transferred onto the Si substrate using a dry etching process (DMS, silicon/metal hybrid etcher). The remaining Cr etching mask was removed by Cr etchant (CR-7).

Fabrication of the soft mold

h-PDMS was prepared by mixing 3.4 g of vinylmethyl copolymers (VDT-731, Gelest), 18 μL of platinum-caralyst (SIP6831.2, Gelest), 0.1 g of the modulator (2,4,6,8- tetramethyl-2,4,6,8-tetravinylcyclotetrasiloxane, Sigma-aldrich), 2 g of toluene, and 1 g of siloxane-based silane reducing agent (HMS-301, Gelest). The *h*-PDMS was spin-coated on the master mold at 1,000 rpm for 60 s, then baked at 70 °C for 2 h. A mixture of a 10:1 weight ratio of PDMS (Sylgard 184 A, Dow corning) and its curing agent (Sylgard 184 B, Dow corning) was poured on the *h*-PDMS layer and cured at 80 °C for 2 h. The cured soft mold was detached from the master mold, then used to replicate the nano-PER structure.

Pre-treatment of the soft mold

Fluorosurfactant ((tridecafluoro-1,1,2,2-tetrahydrooctyl) trichlorosilane) is coated on the soft mold by vaporized coating at 130 °C for 5 min to decrease the surface tension of the soft mold.

Acknowledgements

This work was financially supported by the POSCO-POSTECH-RIST Convergence Research Center program funded by POSCO, a university R&D program funded by Samsung Electronics, and the National Research Foundation (NRF) grants

(NRF-2022M3C1A3081312, NRF-2022M3H4A1A02074314, NRF-2021K1A3A1A17086079, NRF-2021K2A9A2A15000174, CAMM-2019M3A6B3030637, NRF-2019R1A5A8080290) funded by the Ministry of Science and ICT (MSIT) of the Korean government. J.K. and H.Y.K. acknowledge the POSTECH Alchemist fellowships. D.K. acknowledge the Hyundai Motor *Chung Mong-Koo* fellowship. H.J.K. acknowledges the POSTECHIAN fellowship. H.L. acknowledges the NRF grants (NRF-2022M3H4A1A02085335, NRF-2019K1A4A7A02113032, NRF-2018M3D1A1058997) funded by the MSIT of the Korean government, and the Technology Innovation program (20016234) funded by the Ministry of Trade, Industry & Energy of the Korean government.

Author details

[1]Department of Mechanical Engineering, Pohang University of Science and Technology (POSTECH), Pohang 37673, Republic of Korea. [2]Department of Materials Science and Engineering, Korea University, Seoul 02841, Republic of Korea. [3]Department of Chemical Engineering, Pohang University of Science and Technology (POSTECH), Pohang 37673, Republic of Korea. [4]POSCO-POSTECH-RIST Convergence Research Center for Flat Optics and Metaphotonics, Pohang 37673, Republic of Korea. [5]National Institute of Nanomaterials Technology (NINT), Pohang 37673, Republic of Korea

Author contributions

J.R. and H.L. conceived the idea and initiated the project. J.K., H.Y.K., T.B. and S.K. performed the theoretical and numerical simulations. W.K., D.K.O., H.J.K., C.P. and H.C. performed the particle-embedded-resin nanoimprinting. J.K. and D.K.O. contributed to the fabrication of master molds using electron beam lithography. J.K. performed the experimental characterization and data analysis. J.K. and J.R. mainly wrote the manuscript. All the authors confirmed the final manuscript. J.R. guided the entire project.

Data availability

The data that support the findings of this study are available from the corresponding author upon reasonable request.

Conflict of interest

The authors declare no competing interests.

Supplementary information The online version contains supplementary material available at https://doi.org/10.1038/s41377-023-01086-6.

Received: 14 July 2022 Revised: 25 December 2022 Accepted: 31 January 2023
Published online: 08 March 2023

References

1. Fang, N. et al. Sub-diffraction-limited optical imaging with a silver superlens. *Science* **308**, 534–537, https://doi.org/10.1126/science.1108759 (2005).
2. Xu, T. et al. All-angle negative refraction and active flat lensing of ultraviolet light. *Nature* **497**, 470–474, https://doi.org/10.1038/nature12158 (2013).
3. Esposito, L. W. et al. Ultraviolet imaging spectroscopy shows an active saturnian system. *Science* **307**, 1251–1255, https://doi.org/10.1126/science.1105606 (2005).
4. Oto, T. et al. 100 mW deep-ultraviolet emission from aluminium-nitride-based quantum wells pumped by an electron beam. *Nat. Photon.* **4**, 767–770, https://doi.org/10.1038/nphoton.2010.220 (2010).
5. Ludlow, A. D. et al. Optical atomic clocks. *Rev. Mod. Phys.* **87**, 637–701, https://doi.org/10.1103/RevModPhys.87.637 (2015).
6. Campbell, M. et al. Fabrication of photonic crystals for the visible spectrum by holographic lithography. *Nature* **404**, 53–56, https://doi.org/10.1038/35003523 (2000).
7. Greenfield, N. J. Using circular dichroism spectra to estimate protein secondary structure. *Nat. Protoc.* **1**, 2876–2890, https://doi.org/10.1038/nprot.2006.202 (2006).
8. Oppermann, M. et al. Ultrafast broadband circular dichroism in the deep ultraviolet. *Optica* **6**, 56–60, https://doi.org/10.1364/OPTICA.6.000056 (2019).
9. Khorasaninejad, M. et al. Metalenses at visible wavelengths: diffraction-limited focusing and subwavelength resolution imaging. *Science* **352**, 1190–1194, https://doi.org/10.1126/science.aaf6644 (2016).
10. Zhou, Y. et al. Flat optics for image differentiation. *Nat. Photon.* **14**, 316–323, https://doi.org/10.1038/s41566-020-0591-3 (2020).
11. Tittl, A. et al. Imaging-based molecular barcoding with pixelated dielectric metasurfaces. *Science* **360**, 1105–1109, https://doi.org/10.1126/science.aas9768 (2018).
12. Yesilkoy, F. et al. Ultrasensitive hyperspectral imaging and biodetection enabled by dielectric metasurfaces. *Nat. Photon.* **13**, 390–396, https://doi.org/10.1038/s41566-019-0394-6 (2019).
13. Song, Q. H. et al. Plasmonic topological metasurface by encircling an exceptional point. *Science* **373**, 1133–1137, https://doi.org/10.1126/science.abj3179 (2021).
14. Fang, X. Y., Ren, H. R. & Gu, M. Orbital angular momentum holography for high-security encryption. *Nat. Photon.* **14**, 102–108, https://doi.org/10.1038/s41566-019-0560-x (2020).
15. Bao, Y. J. et al. Toward the capacity limit of 2D planar Jones matrix with a single-layer metasurface. *Sci. Adv.* **7**, eabh0365, https://doi.org/10.1126/sciadv.abh0365 (2021).
16. Kim, J. et al. Geometric and physical configurations of meta-atoms for advanced metasurface holography. *InfoMat* **3**, 739–754, https://doi.org/10.1002/inf2.12191 (2021).
17. Naveed, M. A. et al. Novel spin-decoupling strategy in liquid crystal-integrated metasurfaces for interactive metadisplays. *Adv. Opt. Mater.* **10**, 2200196, https://doi.org/10.1002/adom.202200196 (2022).
18. Huang, L. L. et al. Three-dimensional optical holography using a plasmonic metasurface. *Nat. Commun.* **4**, 2808, https://doi.org/10.1038/ncomms3808 (2013).
19. Song, Q. H. et al. Vectorial metasurface holography. *Appl. Phys. Rev.* **9**, 011311, https://doi.org/10.1063/5.0078610 (2022).
20. Song, Q. H. et al. Broadband decoupling of intensity and polarization with vectorial Fourier metasurfaces. *Nat. Commun.* **12**, 3631, https://doi.org/10.1038/s41467-021-23908-0 (2021).
21. So, S. et al. Multicolor and 3D holography generated by inverse-designed single-cell metasurfaces. *Adv. Mater.* **35**, 2208520, https://doi.org/10.1002/adma.202208520 (2023).
22. Joo, W. J. et al. Metasurface-driven OLED displays beyond 10, 000 pixels per inch. *Science* **370**, 459–463, https://doi.org/10.1126/science.abc8530 (2020).
23. Liu, H. L. et al. Tunable resonator-upconverted emission (TRUE) color printing and applications in optical security. *Adv. Mater.* **31**, 1807900, https://doi.org/10.1002/adma.201807900 (2019).
24. Badloe, T. et al. Electrically tunable bifocal metalens with diffraction-limited focusing and imaging at visible wavelengths. *Adv. Sci.* **8**, 2102646, https://doi.org/10.1002/advs.202102646 (2021).
25. Lee, T. et al. Nearly perfect transmissive subtractive coloration through the spectral amplification of mie scattering and lattice resonance. *ACS Appl. Mater. Interfaces* **13**, 26299–26307, https://doi.org/10.1021/acsami.1c03427 (2021).
26. Badloe, T. et al. Liquid crystal-powered Mie resonators for electrically tunable photorealistic color gradients and dark blacks. *Light Sci. Appl.* **11**, 118, https://doi.org/10.1038/s41377-022-00806-8 (2022).
27. Deng, Y. et al. All-silicon broadband ultraviolet metasurfaces. *Adv. Mater.* **30**, 1802632, https://doi.org/10.1002/adma.201802632 (2018).
28. Kim, J. et al. Photonic encryption platform via dual-band vectorial metaholograms in the ultraviolet and visible. *ACS Nano* **16**, 3546–3553, https://doi.org/10.1021/acsnano.1c10100 (2022).
29. Zhang, C. et al. Low-loss metasurface optics down to the deep ultraviolet region. *Light Sci. Appl.* **9**, 55, https://doi.org/10.1038/s41377-020-0287-y (2020).
30. Tseng, M. L. et al. Vacuum ultraviolet nonlinear metalens. *Sci. Adv.* **8**, eabn5644, https://doi.org/10.1126/sciadv.abn5644 (2022).
31. Huang, K. et al. Ultraviolet metasurfaces of ≈80% efficiency with antiferromagnetic resonances for optical vectorial anti-counterfeiting. *Laser Photonics Rev.* **13**, 1800289, https://doi.org/10.1002/lpor.201800289 (2019).
32. Kim, J. et al. Metasurface holography reaching the highest efficiency limit in the visible via one-step nanoparticle-embedded-resin printing. *Laser Photonics Rev.* **16**, 2200098, https://doi.org/10.1002/lpor.202200098 (2022).
33. Yoon, G. et al. Single-step manufacturing of hierarchical dielectric metalens in the visible. *Nat. Commun.* **11**, 2268, https://doi.org/10.1038/s41467-020-16136-5 (2020).

34. Yoon, G. et al. Printable nanocomposite metalens for high-contrast near-infrared imaging. *ACS Nano* **15**, 698–706, https://doi.org/10.1021/acsnano.0c06968 (2021).
35. Kim, K. et al. Facile nanocasting of dielectric metasurfaces with sub-100 nm resolution. *ACS Appl. Mater. Interfaces* **11**, 26109–26115, https://doi.org/10.1021/acsami.9b07774 (2019).
36. Kim, W. et al. Thermally-curable nanocomposite printing for the scalable manufacturing of dielectric metasurfaces. *Microsyst. Nanoeng.* **8**, 73, https://doi.org/10.1038/s41378-022-00403-0 (2022).
37. Von Blanckenhagen, B., Tonova, D. & Ullmann, J. Application of the Tauc-Lorentz formulation to the interband absorption of optical coating materials. *Appl. Opt.* **41**, 3137–3141, https://doi.org/10.1364/AO.41.003137 (2002).
38. Yoon, G. & Rho, J. MAXIM: Metasurfaces-oriented electromagnetic wave simulation software with intuitive graphical user interfaces. *Comput. Phys. Commun.* **264**, 107846, https://doi.org/10.1016/j.cpc.2021.107846 (2021).
39. Lin, D. M. et al. Dielectric gradient metasurface optical elements. *Science* **345**, 298–302, https://doi.org/10.1126/science.1253213 (2014).
40. Zheng, G. X. et al. Metasurface holograms reaching 80% efficiency. *Nat. Nanotechnol.* **10**, 308–312, https://doi.org/10.1038/nnano.2015.2 (2015).
41. Odom, T. W. et al. Improved pattern transfer in soft lithography using composite stamps. *Langmuir* **18**, 5314–5320, https://doi.org/10.1021/la020169l (2002).
42. Yang, G. Z. et al. Gerchberg–Saxton and Yang–Gu algorithms for phase retrieval in a nonunitary transform system: a comparison. *Appl. Opt.* **33**, 209–218, https://doi.org/10.1364/AO.33.000209 (1994).